



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: VON AMMON ET AL -9 EXAMINER: J. MONDT  
SERIAL NO.: 09/813,240 GROUP: 2826  
FILED: MARCH 20, 2001  
TITLE: SEMICONDUCTOR WAFER MADE FROM SILICON AND METHOD  
FOR PRODUCING THE SEMICONDUCTOR WAFER

AMENDMENT IN RESPONSE TO NON FINAL OFFICE ACTION

Mail Stop Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Non-Final Office Action dated November 20, 2003, with the time for reply having been extended for three (3) months from February 20, 2004 until MAY 20, 2004, please amend the above-identified patent application as follows:

**Amendments to the Specification** begin on Page 2 of this document.

**Amendments to the Claims** begin on Page 4 of this document.

**Remarks/Arguments** begin on page 6 of this document.